

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Koji SHIGEMURA et al.

Application No. 10/718,640

Group Art Unit: 2879

Confirmation No. 1164

Filed: November 24, 2003

Examiner: Natalie K. Walford

For: EVAPORATION MASK, METHOD OF FABRICATING ORGANIC  
ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC  
ELECTROLUMINESCENT DEVICE

**SUBMISSION OF COMPLETE COPIES OF REFERENCES PREVIOUSLY  
CITED IN INFORMATION DISCLOSURE STATEMENT AND REPLACEMENT  
LIST OF REFERENCES CITED BY APPLICANT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A Request for Reconsideration was filed on January 28, 2008, in response to the Office Action of October 31, 2007.

An Information Disclosure Statement (IDS) was filed on June 8, 2004, and was considered by the Examiner in the Office Action of June 29, 2006. JP 10-8239, JP 2000-160323, JP 2001-118780, and a publication entitled "Slit Structure as a Countermeasure for the Thermal Deformation of a Metal Mask" were cited in the IDS of June 8, 2004. A complete copy of the publication was submitted with the IDS of June 8, 2004, but only English abstracts of JP 10-8239, JP 2000-160323, and JP 2001-118780 references were submitted with the IDS of June 8, 2004. The four references cited in the IDS of June 8, 2004, had been cited in a European Search Report mailed on March 30, 2004. A copy of the European Search Report was submitted with the IDS of June 8, 2004, but the European Search Report was not listed in the List of References Cited by Applicant included in the IDS of June 8, 2004.

Accordingly, attached hereto are complete copies of JP 2000-160323 and JP 2001-118780 (each including an English Abstract), and a replacement List of References Cited by Applicant that replaces the List of References Cited by Applicant included in the IDS of June 8, 2004, and also lists the European Search Report.

A complete copy of JP 10-8239 is not being provided with this paper because the Examiner provided a machine English translation of JP 10-8239 with the Office Action of February 21, 2007; the applicants provided a complete copy of JP 10-8239 (including an English abstract) with the Request for Reconsideration of May 21, 2007; and the Examiner provided a human English translation of JP 10-8239 with the Final Office Action of September 11, 2007.

It is respectfully requested that the Examiner provide a copy of the replacement List of References Cited by Applicant attached hereto initialed and signed by the Examiner to indicate that the five cited references have been considered with the next Office Action.

If there are any additional fees associated with the filing of this paper, please charge the same to our Deposit Account No. 503333.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: \_\_\_\_\_

02/21/08

By: \_\_\_\_\_

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Attachments